

Docket No.: 52352-785

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

George Jonathan KLUTH, et al.

Serial No.:

Group Art Unit:

Filed: February 11, 2002

Examiner:

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE WITH
SUPERSATURATED SOURCE/DRAIN EXTENSIONS AND METAL SILICIDE
CONTACTS



CLAIM OF PRIORITY

Commissioner for Patents
Washington, DC 20231

Sir:

In accordance with the provisions of 35 U.S.C. 119, Applicants hereby claim the priority of:

United States Provisional Patent Application No. 60/267,407, filed February 9, 2001

Respectfully submitted,

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